



PTO/SB/08A (08-03)

Substitute for form 1449A/PTO				<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				Application Number	10/603,573
				Filing Date	June 24, 2003
				First Named Inventor	Tai, Yu-Chong
				Art Unit	1753
				Examiner Name	Unassigned
Sheet	1	of	2	Attorney Docket Number	020859-002410US

U.S. PATENT DOCUMENTS+						
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
UP	AA	US 6,572,749	B1	06-03-2003	Paul et al.	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				

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NON PATENT LITERATURE DOCUMENTS			
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LR	AB	HARRIS, Shrinking the LC Landscape, Analytical Chemistry, February 1, 2003, pp. 64-69.	
↓	AC	High Performance Liquid Chromatography (HPLC): A Users Guide, <a href="http://www.pharm.uky.edu/ASRG/HPLC.hplcmtry.html">http://www.pharm.uky.edu/ASRG/HPLC.hplcmtry.html</a> , printed 6/19/03.	

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INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

Date Submitted: August 11, 2005

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1 of 3

## Complete if Known

Application Number	10/603,573
Filing Date	06/24/2003
First Named Inventor	Yu-Chong TAI
Group Art Unit	1753
Examiner Name	Unassigned
Attorney Docket Number	049411-0248

## U.S. PATENT DOCUMENTS

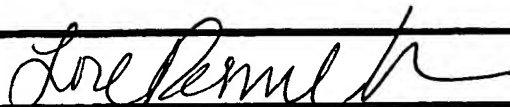
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		Number	Kind Code <sup>2</sup> (if known)			
UR	B1	09/442,843		Tai et al.	11-18-1999	
	B2	2003-0008192	A1	Tai et al.	01-09-2003	
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	B13	6,709,604	B2	Tai et al.	03-23-2004	

## FOREIGN PATENT DOCUMENTS

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UR	B14	BÖHM, et al., "A closed-loop controlled electrochemically actuated micro-dosing system," J. Micromech., Microeng. Vol. 10, pp. 498-504, (2000).	
	B15	CAMERON et al., "Electrolytic actuators: Alternative, high performance, material-based devices," PNSA, Vol. 99, No. 12, pp. 7827-7831, (June 11, 2002).	
	B16	CHEN et al., "A Planar Electroosmotic Micropump," Journal of Microelectromechanical Systems, Vol. 11, No. 6, pp. 672-683, (December 2002).	
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  Date Submitted: August 11, 2005  (use as many sheets as necessary)				Application Number	10/603,573
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				First Named Inventor	Yu-Chong TAI
				Group Art Unit	1753
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Sheet	2	of	3	Attorney Docket Number	049411-0248

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JR	B18	DASGUPTA et al., "Electroosmosis: A Reliable Fluid Propulsion System for Flow Injection Analysis," Analytical Chemistry, Vol. 66, No. 11, pp. 1792-1798, (June 1, 1994).	
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	B28	NEAGU et al., "An electrochemical active valve," Electrochimica Acta, Vol. 42, No. 20-22, pp. 3367-3373, (1997).	
	B29	NEAGU et al., "An Electrochemical Microactuator: Principle and First Results," Journal of Microelectromechanical Systems, Vol. 5, No. 1, pp. 2-9	
	B30	NGUYEN et al., "MEMS - Micropumps: A Review," Transactions of the ASME, Vol. 124, pp. 384-392, (June 2002).	
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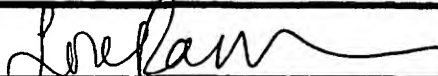
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